

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): OKUBO, et al.

CONFIRMATION NO.: 6494

U.S. Serial No.: 10/593,137

Group Art Unit: 1796

Filed: September 18, 2006

Examiner: FINK, Briann R.

For: RESIN COMPOSITION AND SEMICONDUCTOR DEVICE PRODUCED BY
USING THE SAME

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in Japanese Office Action for Japanese Application No. 2006-511210 issued on December 28, 2010 and the Supplementary European Search Report for Application No. EP 05 72 0935 issued on January 14, 2011 being submitted herewith. A copy of documents AH-AJ cited is enclosed.


Applicants certify under 37 C.F.R. 1.97(e)(1) that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that the documents be listed on the face of any patent which may issue from this application.

A Final Office Action on the merits has issued for this application. In accordance with the requirements of 37 C.F.R. §1.97(c), Applicants also submit payment of the \$180 requisite fee (37 C.F.R. §1.17(p)).

Respectfully submitted,
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By:


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March 25, 2011